

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
Serial No. : 10/519,724  
Filed : December 28, 2004  
For : DEVICE AND METHOD FOR THE PRODUCTION OF  
CHLORINE TRIFLUORIDE AND SYSTEM FOR  
ETCHING SEMICONDUCTOR SUBSTRATES USING  
THIS DEVICE  
Examiner : Rakesh Dhingra  
Art Unit : 1792  
Confirmation No. : 5180

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on **August 10, 2009**.

Signature: /Elizabeth Tretter/  
Elizabeth Tretter

**AMENDMENT**

S I R:

In response to the Office Action of February 10, 2009, (the three-month response date for which is May 10, 2009), kindly amend the above-captioned application without prejudice as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.

Applicants respectfully request a three month extension of time in which to file this response and provide payment of the required fee in the accompanying transmittal.